



THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

**ONO, Toshiaki et al.**

Group Art Unit: 1765

Serial No.: 09/883,922

Examiner: ANDERSON, Matthew A.

Filed: June 20, 2001

Confirmation No.: 3735

For: **METHOD OF MANUFACTURING EPITAXIAL WAFER AND METHOD OF PRODUCING SINGLE CRYSTAL AS MATERIAL THEREFOR**

Attorney Docket No.: 010789  
Customer Number: 38834

**AMENDMENT UNDER 37 C.F.R. §1.116**

Mailstop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

March 3, 2004

Sir:

In response to the Office Action dated September 11, 2003, Applicant amends the claims as follows and submits the following remarks.

**Amendments to the Claims** are reflected in the listing of claims that begins on page 2 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.